



## UNITED STATES PATENT AND TRADEMARK OFFICE

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B1B Data Sheet

CONFIRMATION NO. 2137

SERIAL NUMBER 09/824,931	FILING DATE 04/03/2001 RULE	CLASS 435	GROUP ART UNIT 1645	ATTORNEY DOCKET NO. 3381
<b>APPLICANTS</b> Michael P. Mittmann, Palo Alto, CA; Earl A. Hubbell, Los Angeles, CA;				
<b>** CONTINUING DATA</b> THIS APPLN CLAIMS BENEFIT OF 60/265,103 01/29/2001				
<b>** FOREIGN APPLICATIONS</b>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/01/2001				
Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>AM</i>	STATE OR COUNTRY CA	SHEETS DRAWING 14	TOTAL CLAIMS 51
Verified and Acknowledged Examiner's Signature <i>AM</i>	Initials	INDEPENDENT CLAIMS 10		
<b>ADDRESS</b> 22886				
<b>TITLE</b> Photolithographic method and system for efficient mask usage in manufacturing DNA arrays				
FILING FEE RECEIVED 1958	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other <input type="checkbox"/> Credit		